



02/22/02

2-25-02

PATENT

Docket No. 5853-224

PATENT APPLICATION TRANSMITTAL LETTER

Commissioner for Patents
BOX PATENT APPLICATION
 Washington, DC 20231

Transmitted herewith for filing of the patent application of:

Inventor(s): Rajiv K. Singh
 Seung-Mahn Lee



**for SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING OF METAL STRUCTURES
 INCLUDING REFRACTORY METAL BASED BARRIER LAYERS**

are the following:

- ☒ Specification, including Abstract
☒ 10 Sheets of drawing (3 sets)
☒ Executed Declaration and Power of Attorney
☒ Assignment with Recordation Cover Sheet
☒ Other: 2 postcards

CLAIMS AS FILED

| FOR | NO. FILED | NO. EXTRA |
|-------------------------------------|-----------|-----------|
| Basic Fee | | |
| Total Claims | 71 | 51 |
| Indep Claims | 6 | 3 |
| multiple dependent claim present No | | |

If the difference in Col. 1 is less than zero, enter "0" in Col. 2
 Assignment Recordation

Small Entity

| RATE | FEE |
|-----------|-----------|
| | \$ 370.00 |
| x \$ 9 = | \$ 459.00 |
| x \$ 42 = | \$126.00 |
| x \$135 = | \$ |
| TOTAL | \$ 955.00 |
| | \$ 40.00 |

Other than a Small Entity

| RATE | FEE |
|-----------|-----------|
| | \$ 740.00 |
| x \$ 18 = | \$ |
| x \$ 84 = | \$ |
| x \$270 = | \$ |
| TOTAL | \$ |

- ☒ You are hereby authorized to charge \$995.00 to Deposit Account 50-0951.
☒ The Commissioner is hereby authorized to charge any underpayment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-0951. A duplicate of this sheet is enclosed.
☒ Any additional filing fees required under 37 C.F.R. 1.16.
☒ Any patent application processing fees under 37 C.F.R. 1.17.

02/24/02
 Date

Neil R. Jetter
 Registration No.46,803